



UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. 20231
www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 7849

SERIAL NUMBER 09/843,650	FILING DATE 04/27/2001 RULE	CLASS 361	GROUP ART UNIT 2841	ATTORNEY DOCKET NO. IIZ 123
------------------------------------	---	---------------------	-------------------------------	---

APPLICANTS

Shinji Ohuchi, Tokyo, JAPAN;
Yasushi Shiraishi, Tokyo, JAPAN;
Yasuo Tanaka, Tokyo, JAPAN;

** CONTINUING DATA *****

** FOREIGN APPLICATIONS *****

JAPAN 2000-128764 04/28/2000

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 06/22/2001

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 23	TOTAL CLAIMS 22	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature <i>Steven M. Rabin</i>	Initials		

ADDRESS

RABIN & CHAMPAGNE, P.C.
Steven M. Rabin
SUITE 500
1101 14th STREET
Washington, DC 20005

TITLE

Semiconductor apparatus and method for fabricating the same

**FILING FEE
RECEIVED**
876

FEES: Authority has been given in Paper
No. _____ to charge/credit DEPOSIT ACCOUNT
No. _____ for following:

<input type="checkbox"/> All Fees
<input type="checkbox"/> 1.16 Fees (Filing)
<input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
<input type="checkbox"/> 1.18 Fees (Issue)
<input type="checkbox"/> Other _____
<input type="checkbox"/> Credit